

[図1]

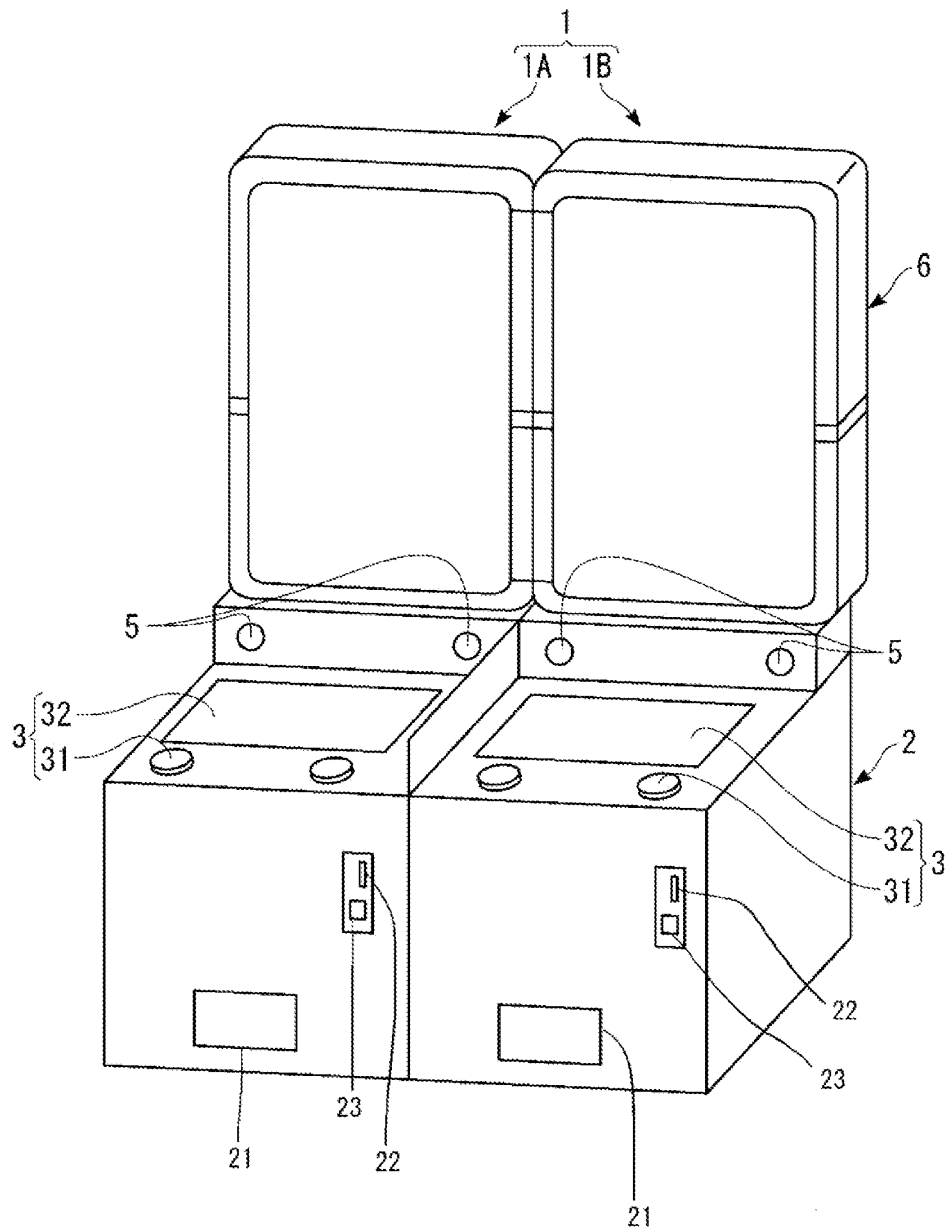


FIG.1

[図2]

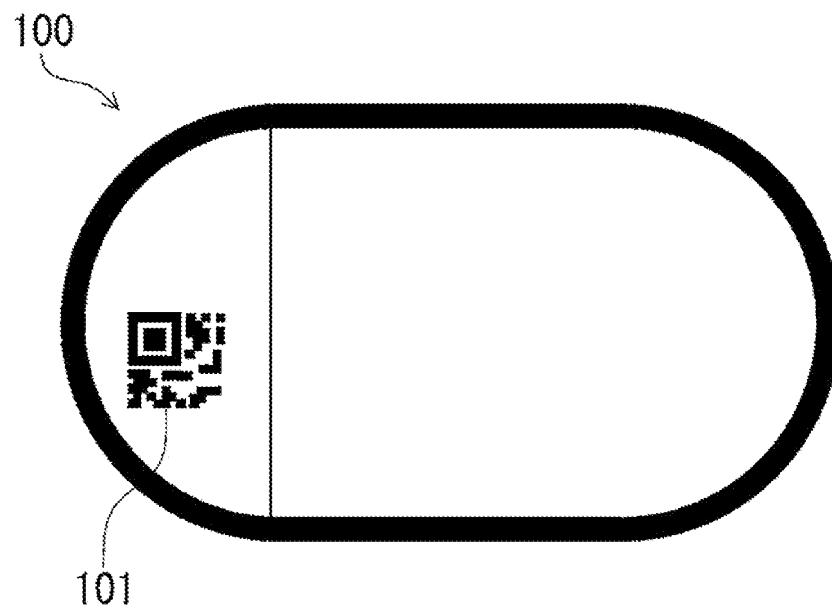


FIG.2

[図3]

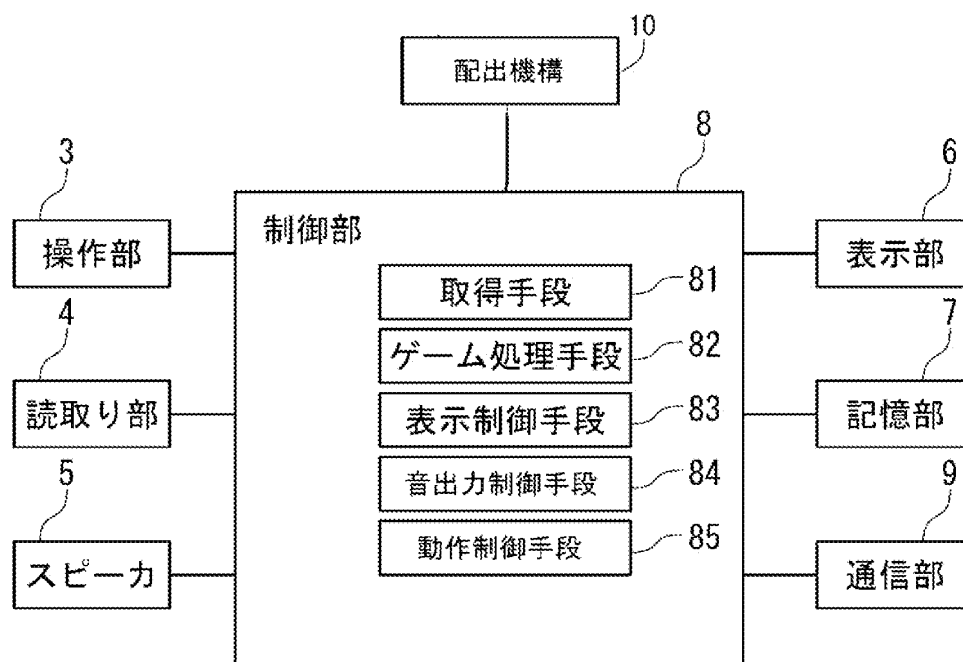


FIG.3

[図4]

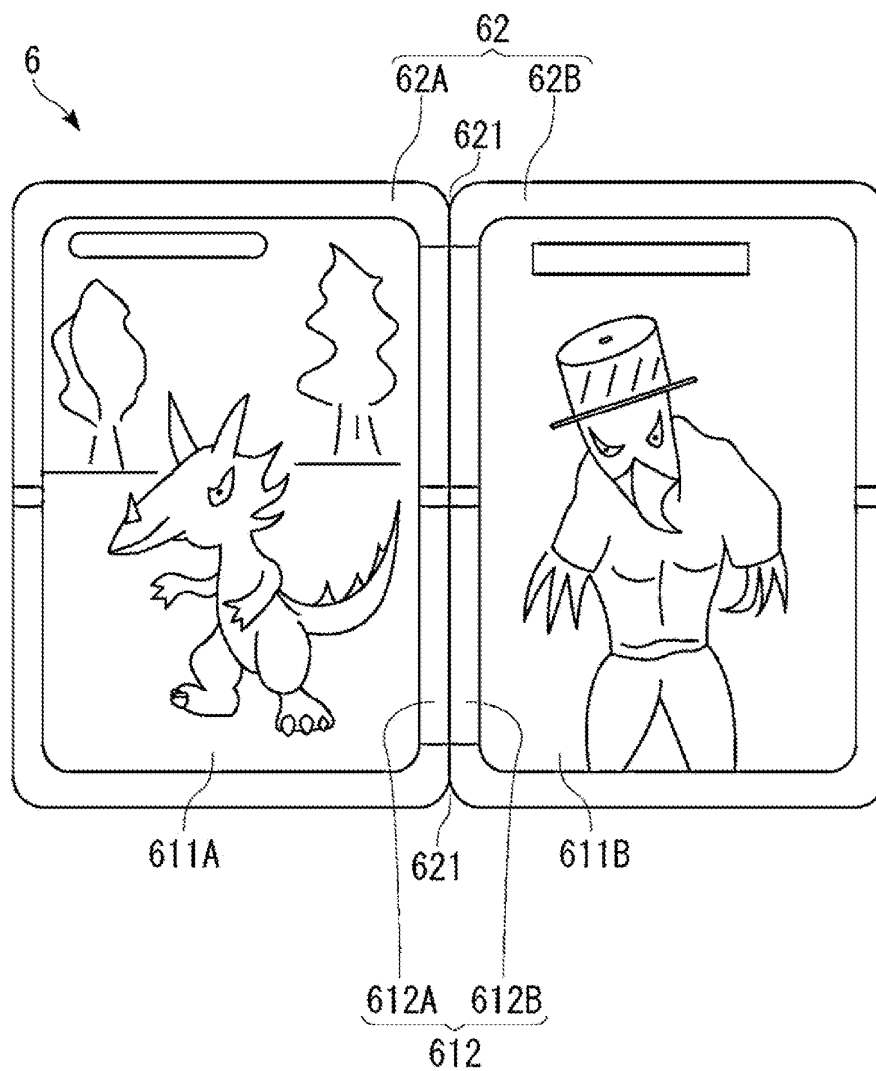


FIG.4

[図5]

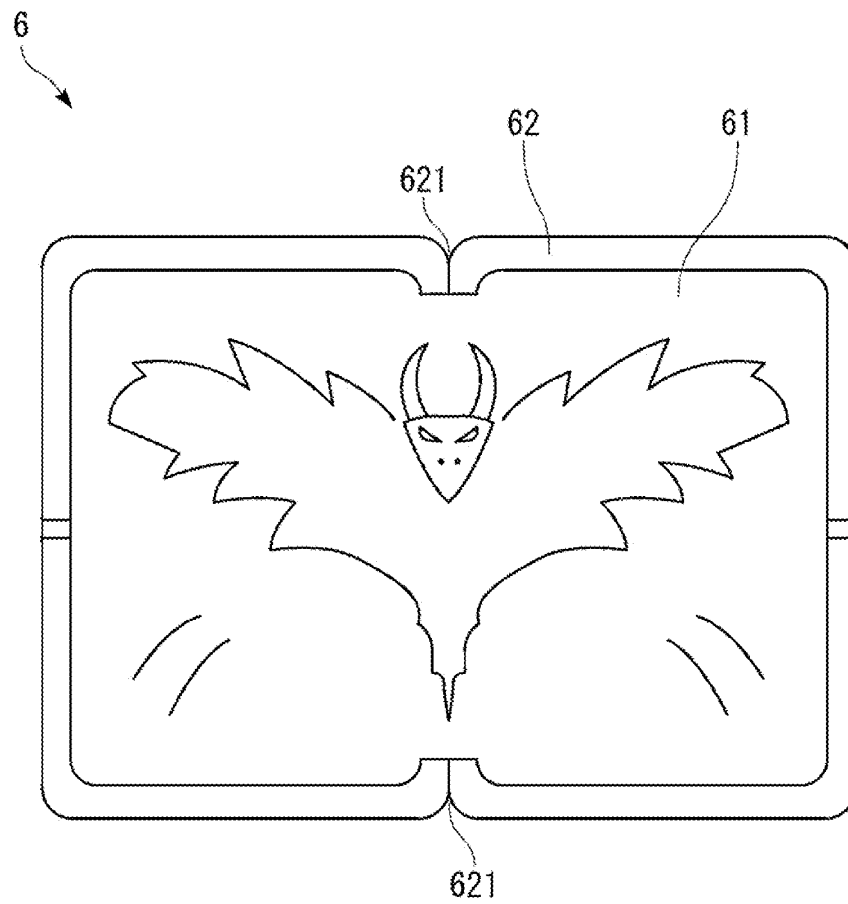


FIG.5

[図6]

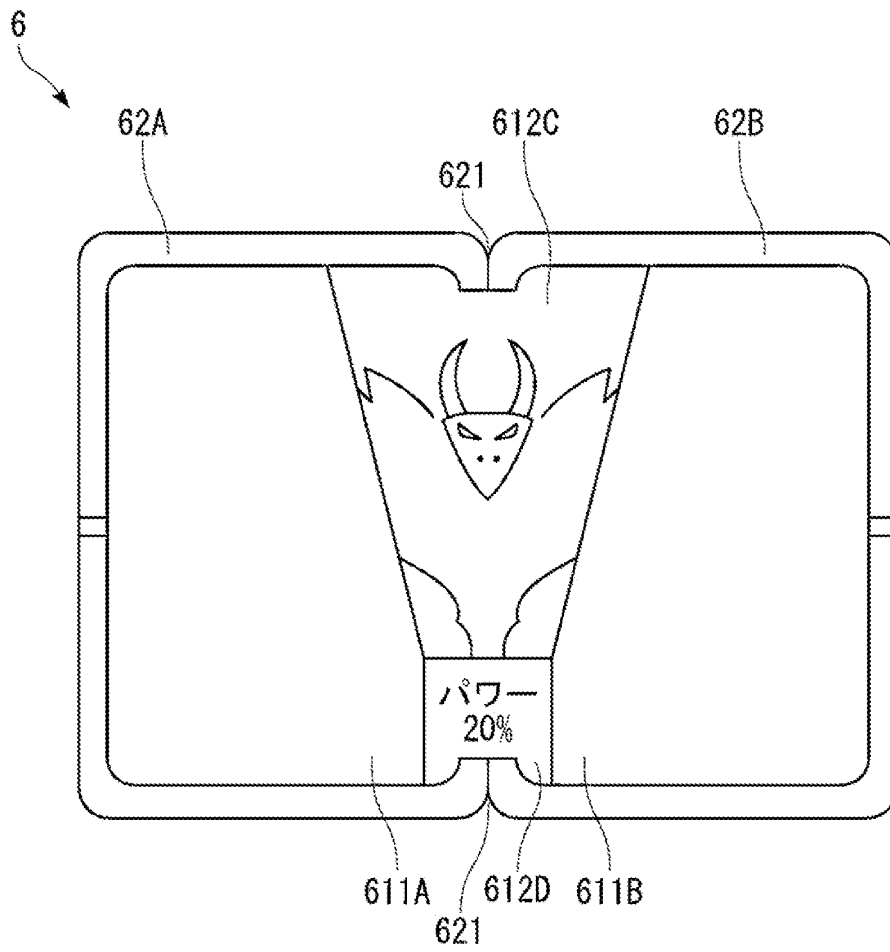


FIG. 6



[図8]

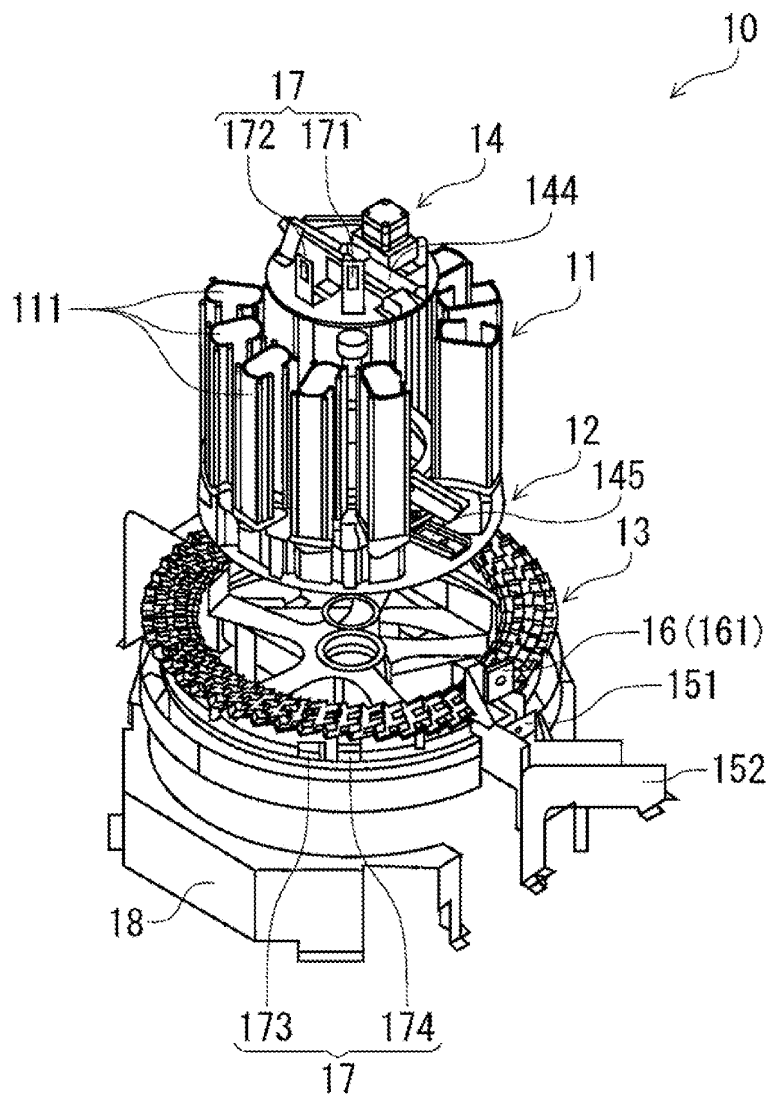


FIG.8

[図9]

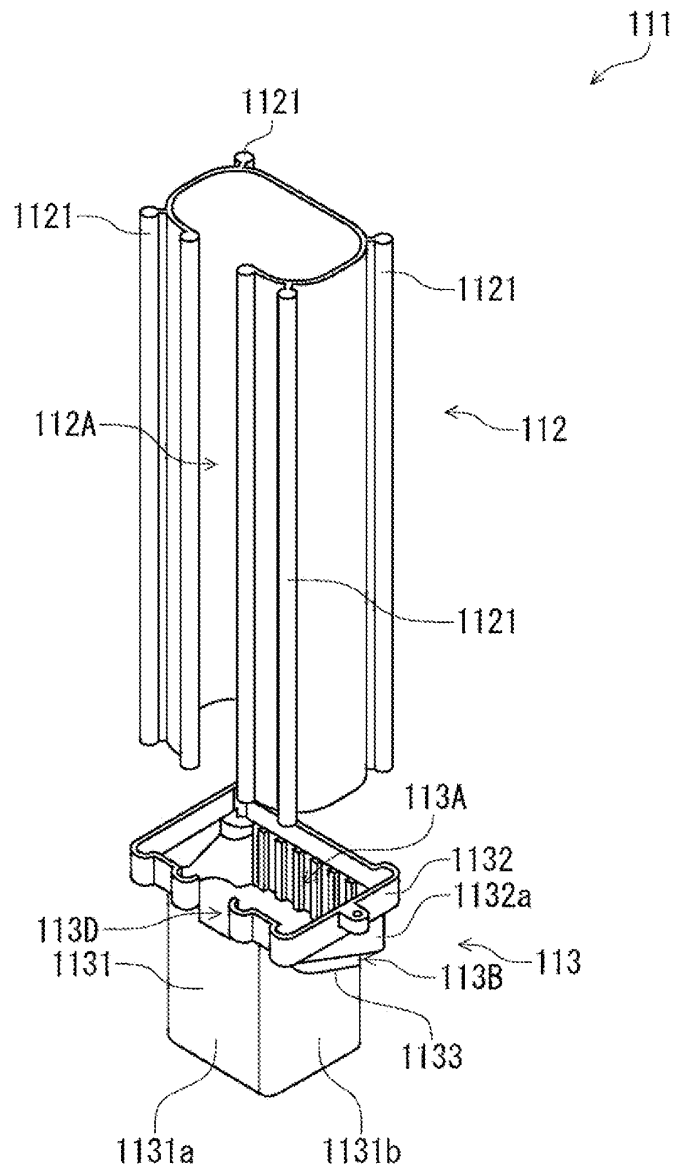


FIG.9

[図10]

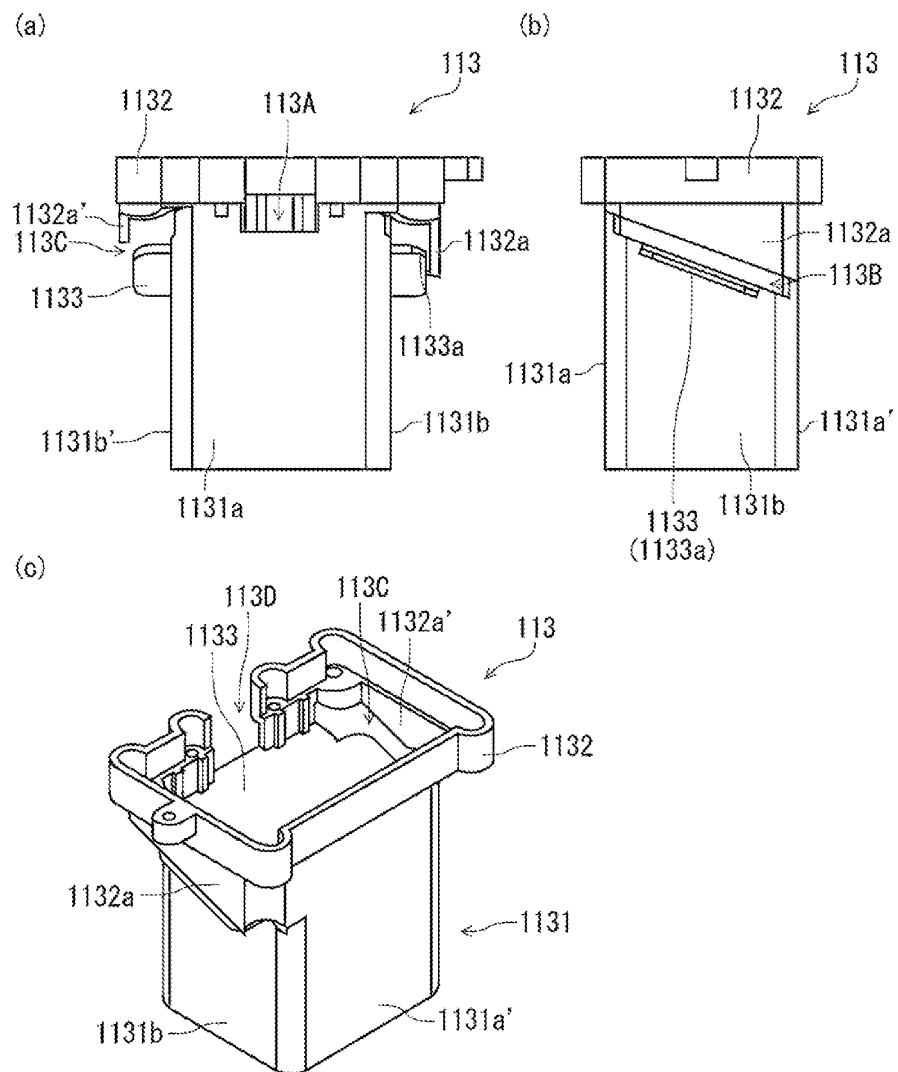


FIG.10

[図11]

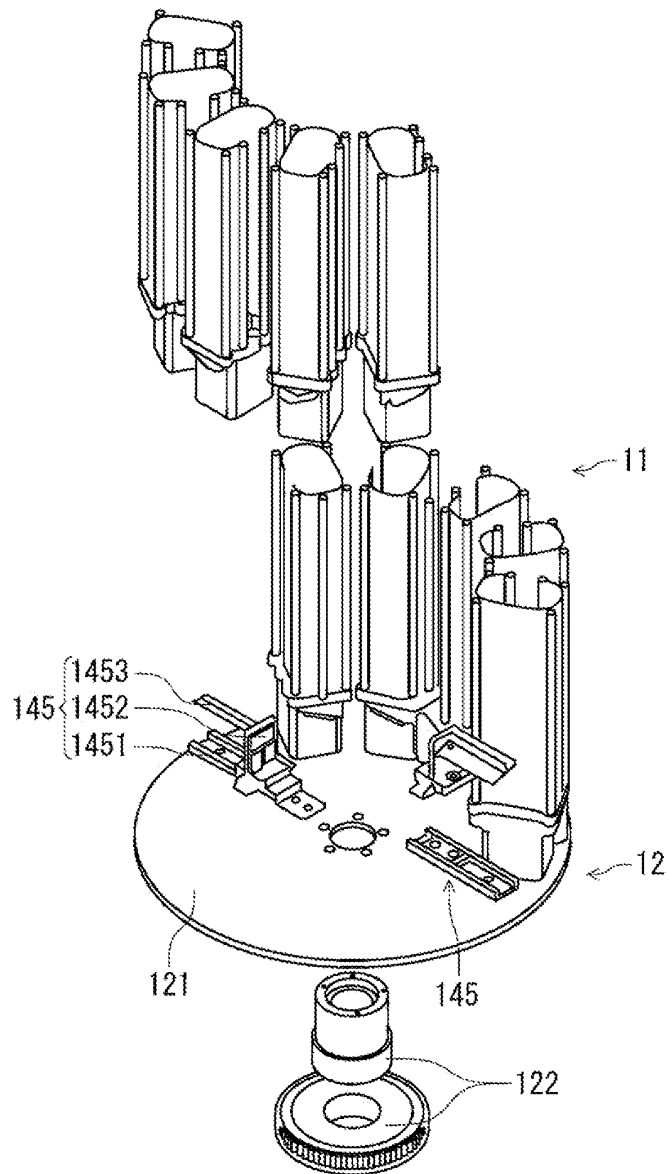


FIG. 11

[図12]

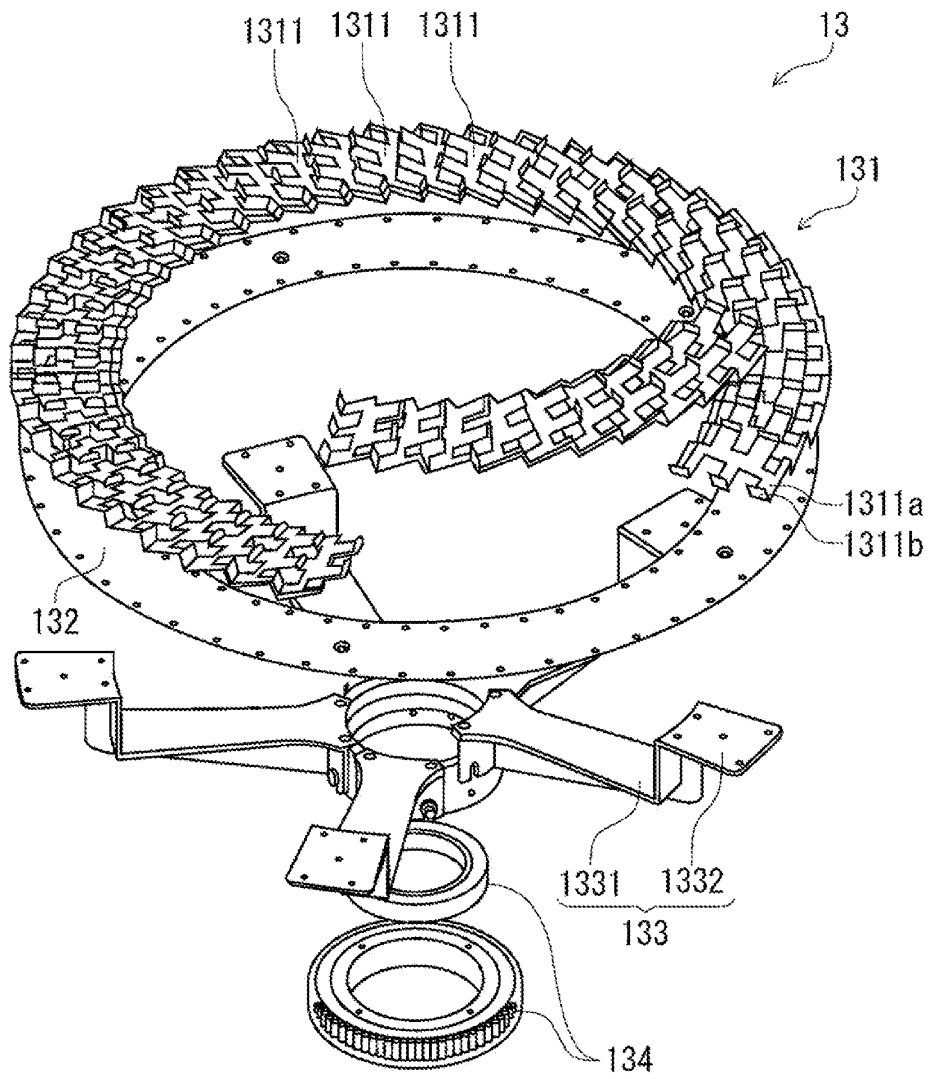


FIG. 12

[図13]

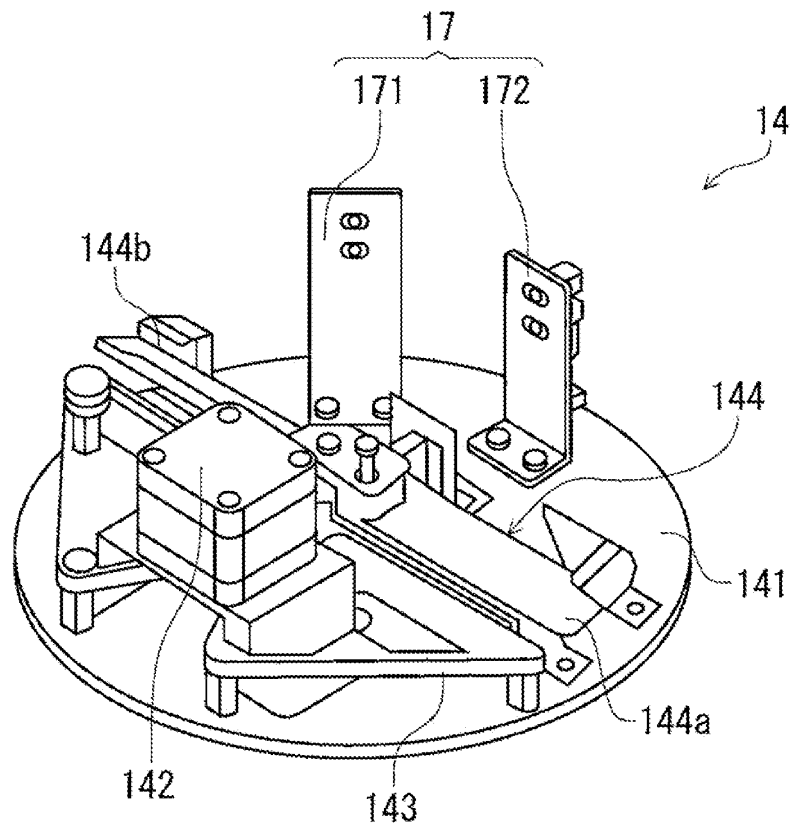


FIG.13

[図14]

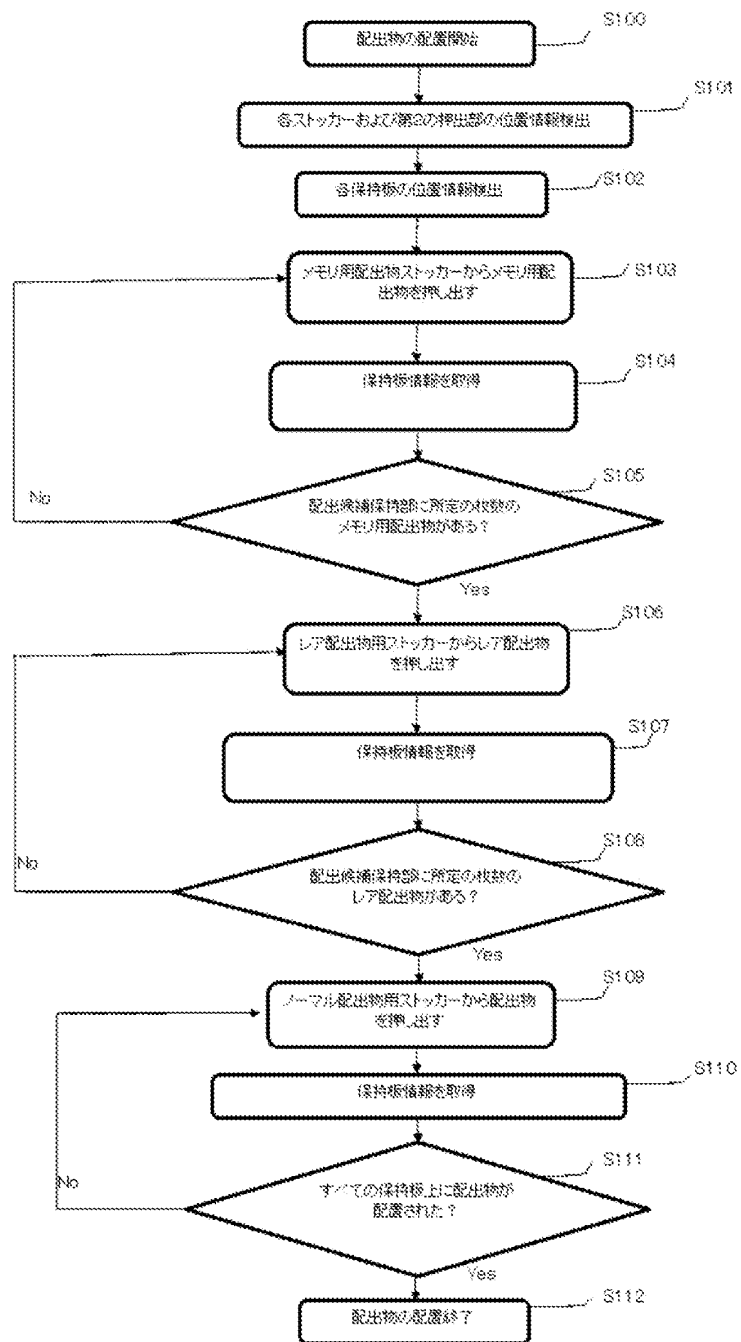


FIG.14

[図15]

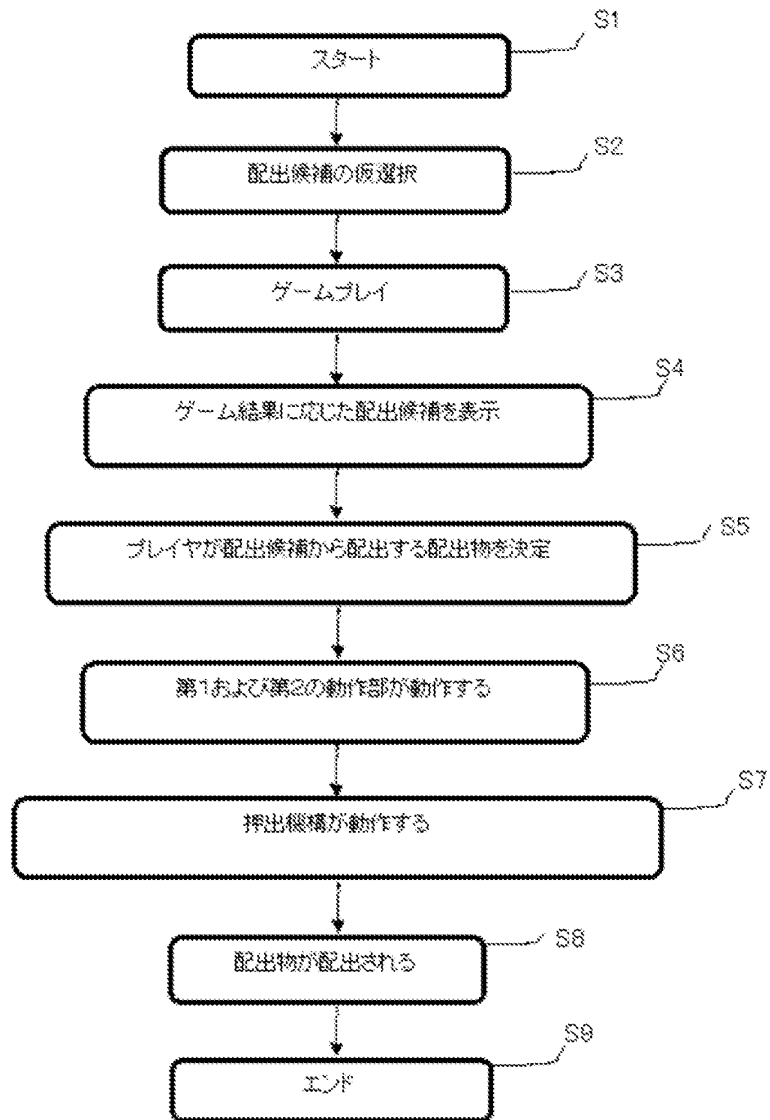


FIG.15

[図16]

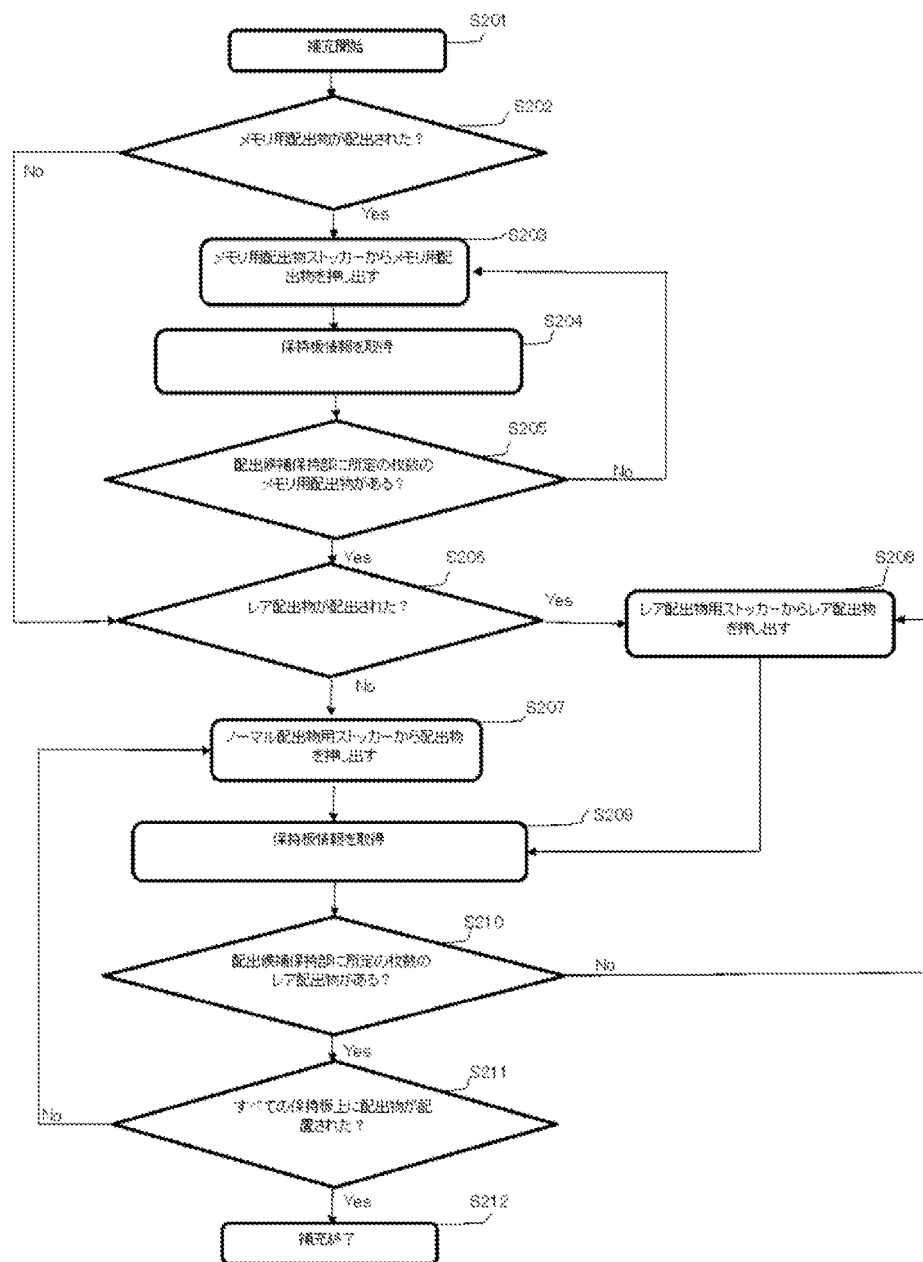


FIG. 16

[図17]

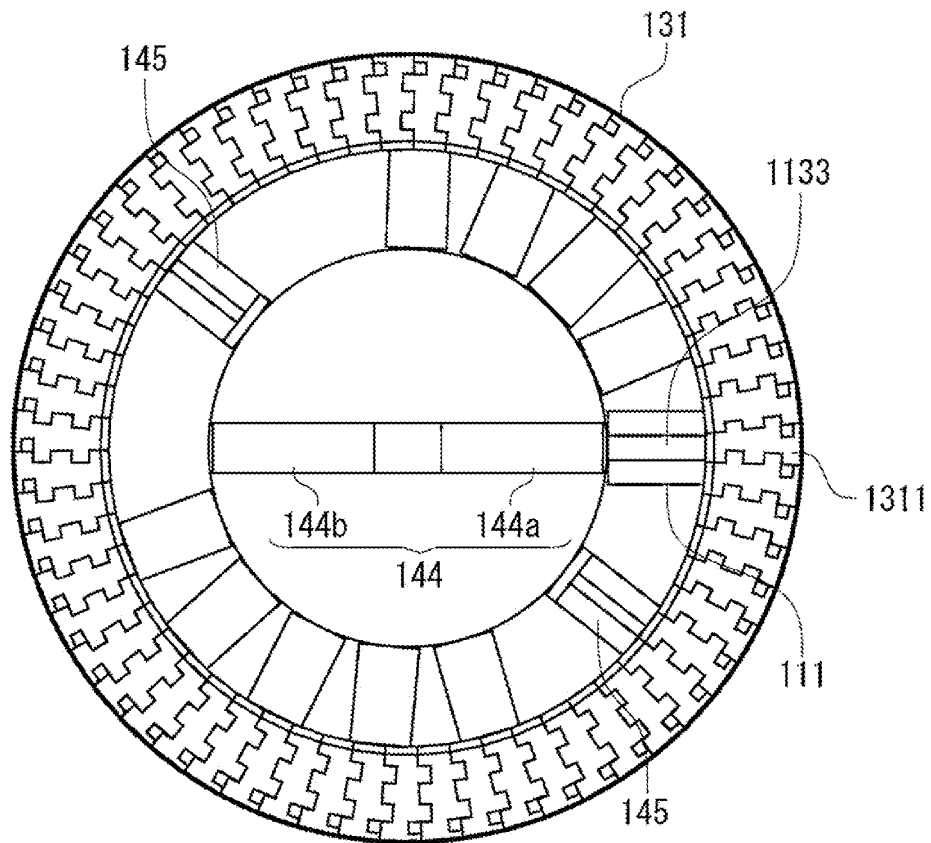


FIG.17

[図18]

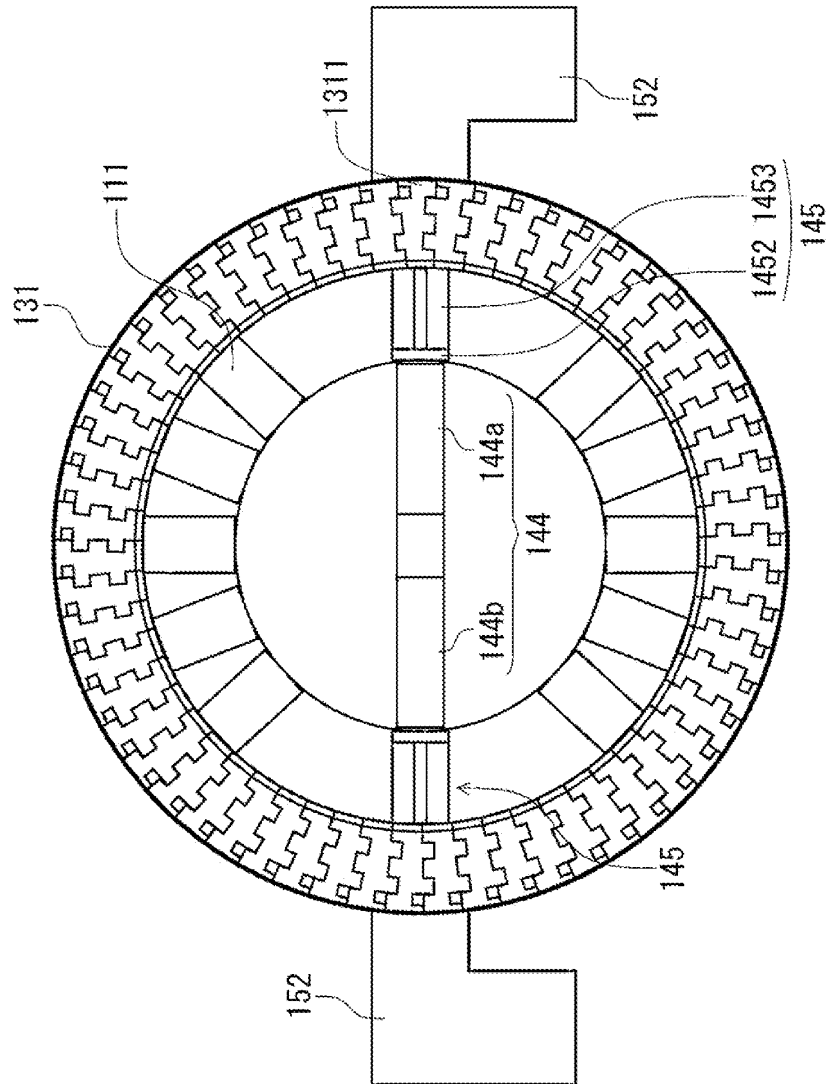


FIG. 18

[図19]

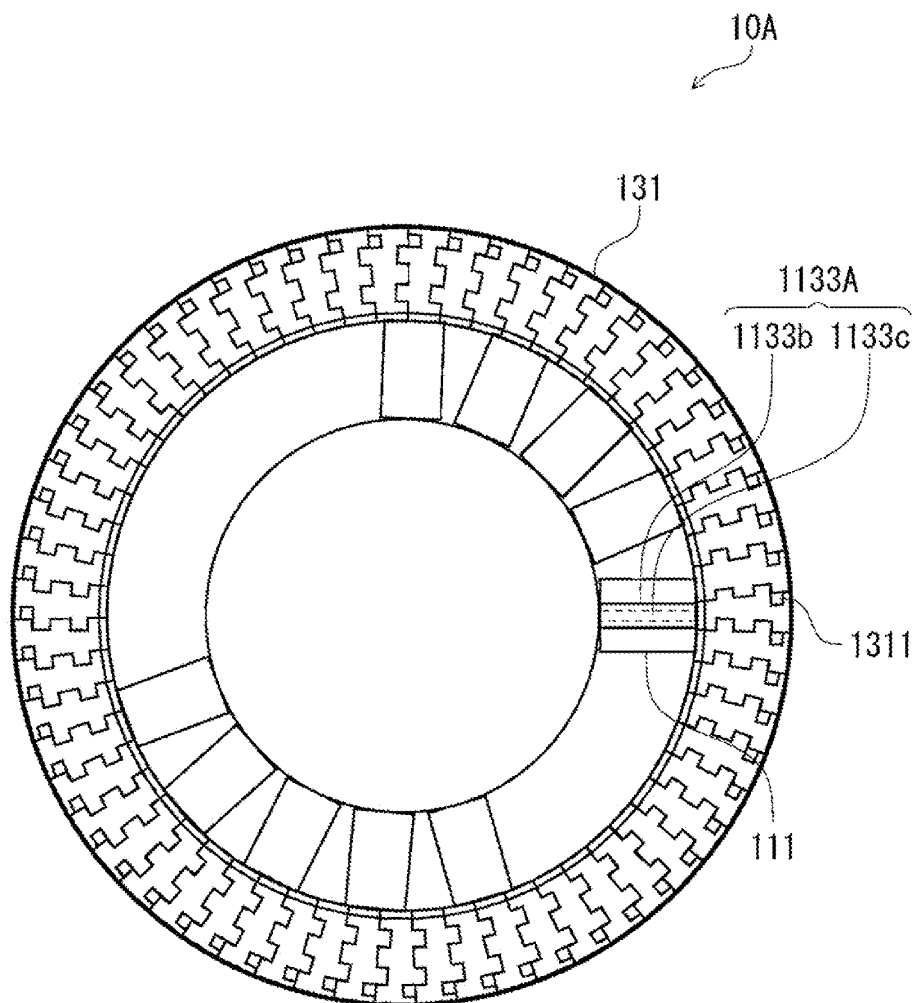


FIG.19

[図20]

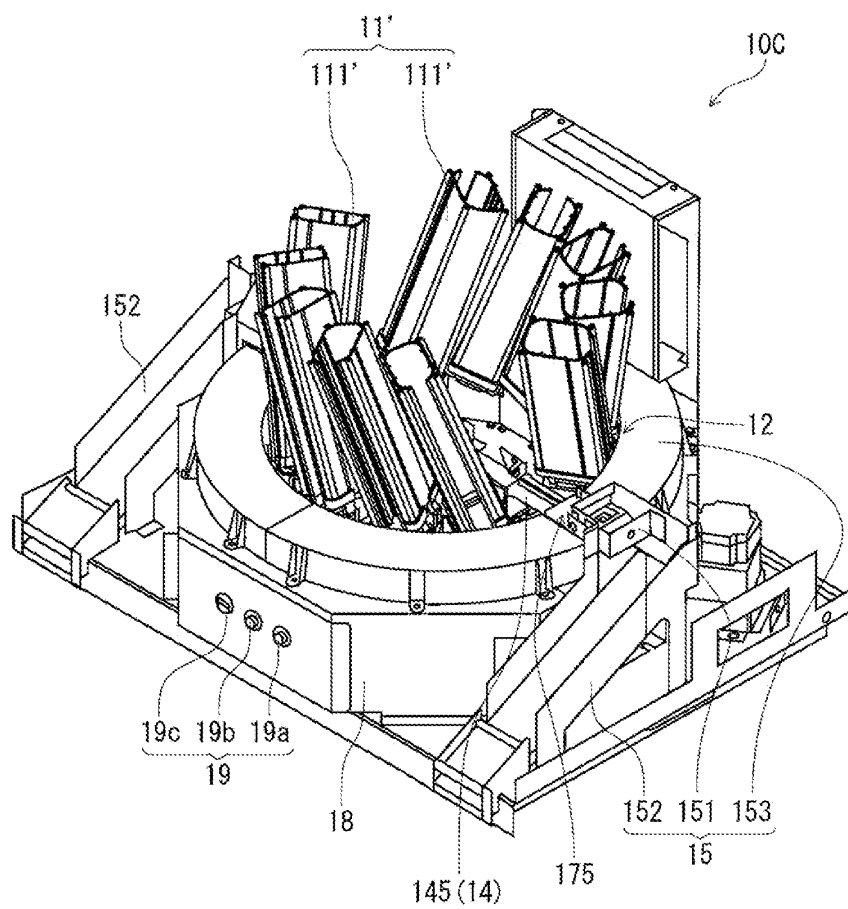


FIG.20

[図21]

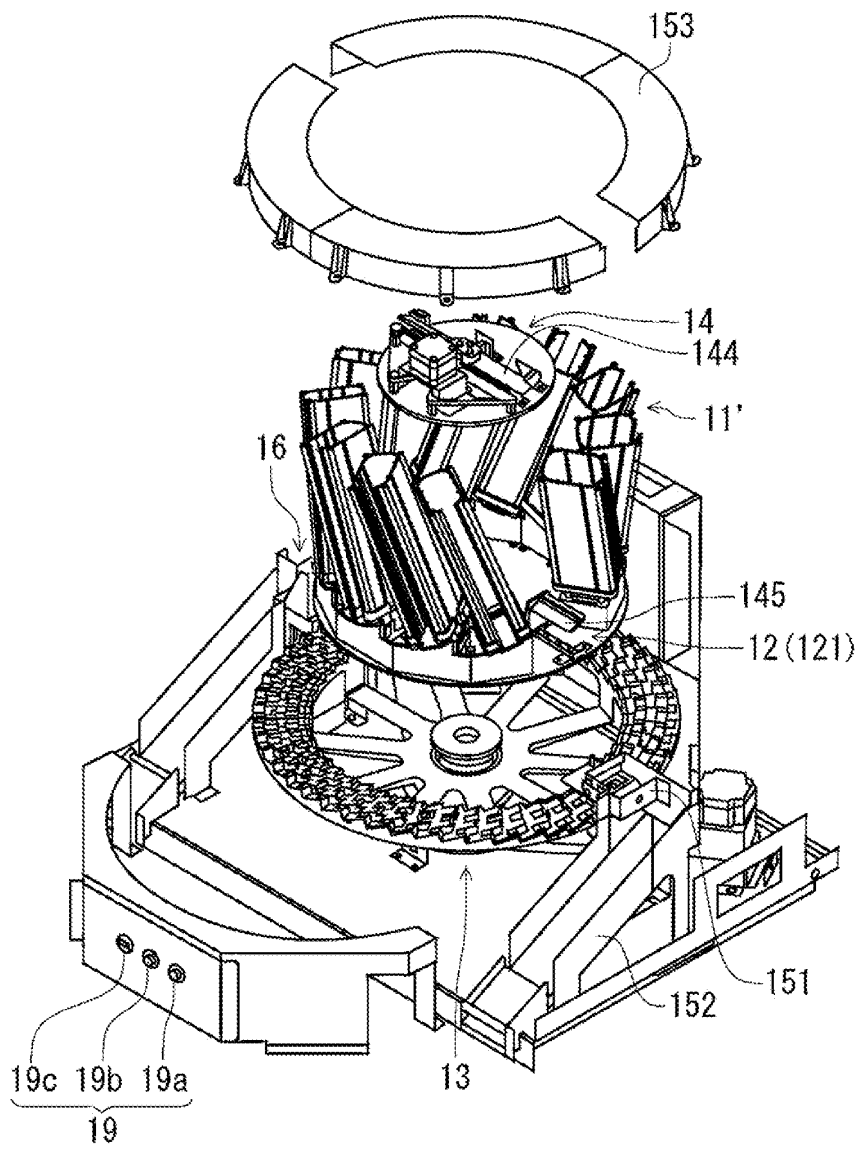


FIG.21

[図22]

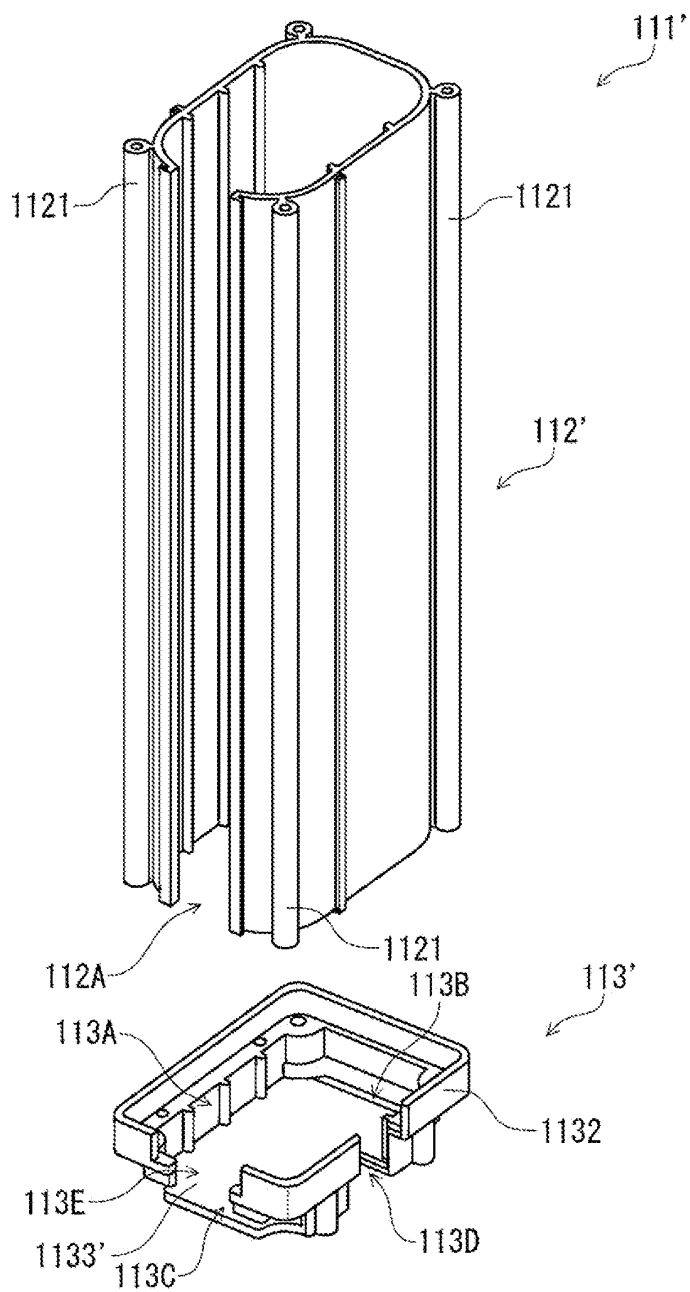


FIG.22

[図23]

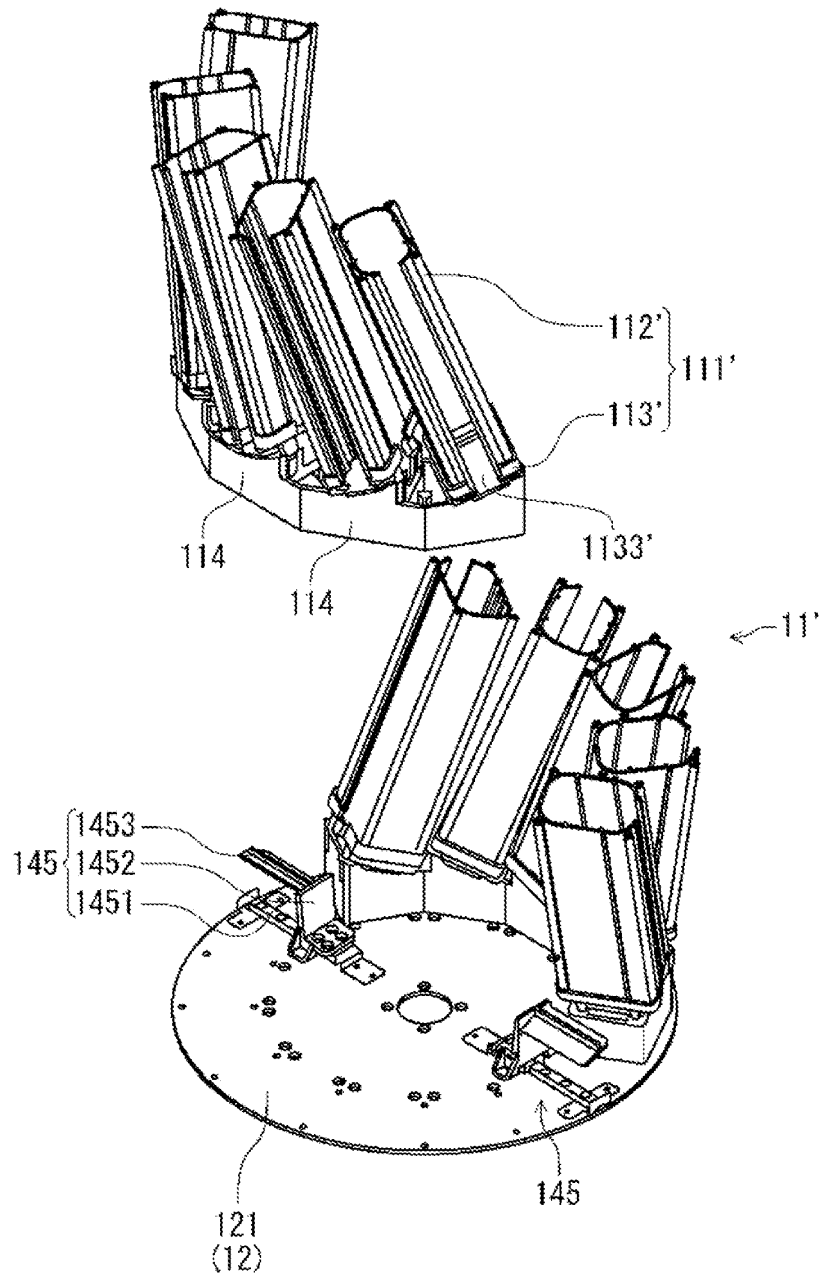


FIG.23